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PATENT

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Kenneth C. Johnson et al.

Application No.: 09/938,415 ✓

Filed: August 23, 2001

For: OPTIMIZED APERTURE SHAPE FOR  
OPTICAL CD/PROFILE METROLOGY

Confirmation No.: 9943

Group Art Unit: 2851

Examiner: Andrew T. Sever

**SUBMISSION OF REPLACEMENT  
FORMAL DRAWINGS**353 Sacramento Street, Suite 2200  
San Francisco, CA 94111  
(415) 772-4900**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 13, 2004.

STALLMAN &amp; POLLOCK LLP

Dated: 10/13/2004 By: Georgia K. Stith  
Georgia K. Stith

Sir:

In response to the Notice of Allowance and Issue Fee(s) Due mailed September 30, 2004, enclosed are three (3) sheets of replacement formal drawings for filing in the above-referenced application.

Respectfully submitted,

STALLMAN &amp; POLLOCK LLP

Dated: October 13, 2004By: Jason D. Lohr  
Jason D. Lohr  
Reg. No. 48,163

Attorneys for Applicant(s)

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